

Receipt date: 03/16/2011

Doc code: IDS

Doc description: Information Disclosure Statement (IDS) Filed

10569869 - GAI: 1787

Approved for use through 07/31/2012. OMB 0651-0031

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number		10569869	
	Filing Date		2006-02-28	
	First Named Inventor	Futoshi Nomura		
	Art Unit	1787		
	Examiner Name	Cheng Yuan Huang		
	Attorney Docket Number	03933.000400.		

U.S.PATENTS							Remove
Examiner Initial*	Cite No	Patent Number	Kind Code ¹	Issue Date	Name of Patentee or Applicant of cited Document	Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear	
	1	5683774		1997-11-04	Faykish et al.		

If you wish to add additional U.S. Patent citation information please click the Add button.

Add

U.S.PATENT APPLICATION PUBLICATIONS							Remove
Examiner Initial*	Cite No	Publication Number	Kind Code ¹	Publication Date	Name of Patentee or Applicant of cited Document	Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear	
	1	20080198461		2008-08-21	Nomura et al.		
	2	20080226906		2008-09-18	Nomura et al.		

If you wish to add additional U.S. Published Application citation information please click the Add button.

Add

FOREIGN PATENT DOCUMENTS								Remove
Examiner Initial*	Cite No	Foreign Document Number ³	Country Code ²	Kind Code ⁴	Publication Date	Name of Patentee or Applicant of cited Document	Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear	T ⁵
	1	56-35659	JP		1981-04-06	Seibu Polymer Kase Kabushiki Kaisha		<input type="checkbox"/>
	2	0 102 818	EP		1984-03-14	Minnesota Mining and Manufacturing Company		<input type="checkbox"/>

Receipt date: 03/16/2011

Application Number

10569869

10569869 - GAU: 1787

Filing Date

2006-02-28

First Named Inventor

Futoshi Nomura

Art Unit

1787

Examiner Name

Cheng Yuan Huang

Attorney Docket Number

03933.000400.

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Not for submission under 37 CFR 1.99)

3	06-043819	JP		1994-02-18	Nippon Carbide Inc Co Inc	<input type="checkbox"/>
4	97/30363	WO		1997-08-21	Minnesota Mining and Manufacturing Company	<input type="checkbox"/>
5	97/44769	WO		1997-11-27	Minnesota Mining and Manufacturing Company	<input type="checkbox"/>
6	98/22837	WO		1998-05-28	Minnesota Mining and Manufacturing Company	<input type="checkbox"/>
7	99/55791	WO		1999-11-04	Minnesota Mining and Manufacturing Company	<input type="checkbox"/>
8	2000-265012	JP		2000-09-26	Mitsui Chemicals Inc.	<input type="checkbox"/>
9	1 225 554	EP		2002-07-24	3M Innovative Properties Company	<input type="checkbox"/>
10	2005-024990	JP		2005-01-27	Nippon Carbide Ind Co Inc	<input type="checkbox"/>
11	2005/022211	WO		2005-03-10	Nippon Carbide Kogyo Kabushiki Kaisha	<input type="checkbox"/>

If you wish to add additional Foreign Patent Document citation information please click the Add button

Add**NON-PATENT LITERATURE DOCUMENTS****Remove**

Examiner Initials*	Cite No	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, pages(s), volume-issue number(s), publisher, city and/or country where published.	T5
--------------------	---------	---	----

Receipt date: 03/16/2011 INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number		10569869	10569869 - GAU: 1787
	Filing Date		2006-02-28	
	First Named Inventor	Futoshi Nomura		
	Art Unit	1787		
	Examiner Name	Cheng Yuan Huang		
	Attorney Docket Number	03933.000400.		

1		<input type="checkbox"/>
---	--	--------------------------

If you wish to add additional non-patent literature document citation information please click the Add button Add

EXAMINER SIGNATURE

Examiner Signature	/Cheng Yuan Huang/	Date Considered	06/22/11
--------------------	--------------------	-----------------	----------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through a citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ See Kind Codes of USPTO Patent Documents at www.USPTO.GOV or MPEP 901.04. ² Enter office that issued the document, by the two-letter code (WIPO Standard ST.3). ³ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁴ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁵ Applicant is to place a check mark here if English language translation is attached.